

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

## Title of Invention

OXIDATION METHOD FOR ALTERING A FILM STRUCTURE  
AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH

Application Number :

Confirmation Number:

First Named Applicant: Michael Belyansky

Attorney Docket Number: FIS920030286US1

Art Unit:

Examiner:

Search string: ( 5847419 or 6316820 or 6504235 or 6538278 or 20020197803 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5847419	1998-12-08	Imai, et al.			
	2	6316820	2001-11-13	Schmitz, et al.			
	3	6504235	2003-01-07	Schmitz, et al.			
	4	6538278	2003-03-25	Chau			

## US Published Applications

**Note: Applicant is not required to submit a paper copy of cited US Published Applications**

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20020197803	2002-12-26	Leitz, et al.			

## Signature

Examiner Name	Date